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X	25/2	A9	4,510,176	04-09-1985	Cuthbert, et al.	427	82	09-26-1983	3
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Sheet 1 of 1 sheet(s) U.S. Department of Commerce, Patent and Trademark Office Docket No. Serial No. APPM/4582 09/853.962 (PTO Form 1449 modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT Confirmation No.: Applicant 6593 Hey, et al. SEP 2 5 2002 Filing Date Group (Use several sheets if necessary) Unknown R. Koebler May 10, 2001 Examiner RADEMAR U.S. Patent Documents Document Issue Applicant(s) Class Subclass Filing Date \*Examiner Initial Number Date Name Appropriate 356 437 Α1 5.384.640 01/24/95 Wona 01/19/83 205 123 03/20/98 A2 6,197,181 03/06/01 Chen 205 103 10/14/98 **A3** 6.203.684 03/20/01 Taylor, et al. 01/29/99 205 103 04/03/01 Taylor, et al. A4 6.210.555 205 123 08/19/99 **A5** 6.224.737 05/01/01 Tsai, et al. 05/08/01 Kust, et al. 141 86 02/04/00 A6 6,227,263 04/21/99 07/17/01 Landau 205 96 Α7 6.261.433 205 182 08/31/99 **8**A 6.290.833 09/18/01 Chen 10/16/01 Taylor, et al. 205 103 04/20/00 Α9 6.303.014 103 04/20/00 A10 6.319.384 11/20/01 Taylor, et al. 205 438 678 12/18/00 A11 6,432,821 08/13/02 Dubin, et al. A12 A13 A14 **Foreign Patent Documents** Subclass Translation Document Date Country Class \*Examiner Initial Number YES NO BRX 21 H01L 21/302 JΡ B1 53086580 07-31-1998 82 OTHER ART \*Examiner Including Author, Title, Date, Pertinent Pages, Etc. Initial G1 C2 Amela, 2 es Examiner Date Considered \*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through

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7	RX.	$\top$	A3	6,350,366	02/26/02	Landau, et al.	205	182	01/18/00		
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8	RX.	Π	A8	6,254,760	07/03/01	Shen, et al.	205	335	03/05/99		
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16	BX.		A11	6,093,291	07/25/00	Izumi, et al.	204	224R	7/31/98		
B	88.		A12	6,071,388	06/06/00	Uzoh	204	297 R	05/29/98		
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	X.	T	A2	5,730,890	03	3/24/98	Bickf	ord, et al.		216	87	09/12/96	
a	RX.	T	A3	5,705,223	01	/06/98	Bunk	ofske		427	240	12/05/95	
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d	<b>SX.</b>		A6	5,608,943	03	3/11/97	Konis	shi, et al.		15	302	08/22/94	
Ø	RX		A7	5,528,118	06	6/18/96	Lee			318	568.17	04/01/94	
d	RIC.		A8	5,516,412	05	/14/96	Andri	cacos, et al.		204	224R	05/16/95	
R	RX.		A9	5,454,930	10	/03/95	Miura	ı, et al.		205	159	07/28/94	
R	RX.		A10	5,447,615	09	/05/95	Ishida			204	224R	06/22/94	
Ŕ	K.		A11	5,415,890	05	/16/95	Kloib	er, et al.		427	242	01/03/94	
2	RK!		A12	5,377,708	01	/03/95	Bergr	nan, et al.		134	105	04/26/93	
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R	X.		A6	5,252,807	10/	12/93	Chi	izinsky	219	390	10/23/91	
R			A7	5,230,743	07/2	27/93	The	ompson, et al.	134	32	07/30/92	
FW	Χ.		A8	5,224,504	07/0	06/93	Tho	ompson, et al.	134	155	07/30/92	
R	<b>X.</b>		A9	5,222,310	06/2	29/93	Tho	ompson, et al.	34	202	01/11/91	
K	3.		A10	5,178,813	01/	12/93	Aka	atsu, et al.	264	210.7	03/19/91	
R	. 7		A11	5,162,260	11/	10/92	Leil	bovitz, et al.	437	195	01/07/1	
R			A12	5,155,336	10/	13/92	Gro	onet, et al.	219	411	10/24/91	
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3.		A5	4,519,846	05/	28/85	Aig	0	134	15	03/08/84	
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RK.		A7	4,489,740	12/	25/84	Rai	ttan, et al.	134	140	12/27/82	
		A8	4,428,815	01/3	31/84	Po	well, et al.	204	297 W	04/28/83	
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37.		A12	4,326,940	04/2	27/82	Ec	des, et al.	204	232	05/21/79	
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Serial No. Docket No. U.S. Department of Commerce, Patent and Trademark Office 09/853,962 AMAT/4582/CMP/ (PTO Form 1449 modified) Confirmation
No.:
6593
Group 30 2004 ECP/RKK SUPPLEMENTAL LIST OF PATENTS AND PUBLICATION Applicant Hey, et al. CITED BY APPLICANT Filing Date (Use several sheets if necessary May 10, 2001 Examiner **U.S. Patent Documents** Filing Date If Subclass Class Applicant(s) Issue Document \*Examiner Appropriate Name Date Number Initial 182 11/22/2002 205 Chen, et al 10/28/2003 6,638,410 Α1 10/23/2000 205 182 10/14/2003 Chen 6.632.345 A2 12/07/2000 82 205 Chen, et al 05/20/2003 6.565,729 АЗ 11/30/2000 205 205 08/27/2002 Henri, et al A4 6,440,291 12/21/1999 96 205 06/25/2002 Chung, et al Α5 6.409,903 03/26/1999 625 438 Lopatin, et al 01/22/2002 6,340,633 Α6 08/31/1999 182 205 08/21/2001 Chen, et al. Α7 6,277,263 07/22/1998 205 157 Reid, et al 06/13/2000 **A8** 6.074,544 08/18/1987 204 30 Domnikov 01/02/1990 Α9 4.891,106 A10 A11 A12 A13 **Foreign Patent Documents** Translation Subclass Class Country Document Date \*Examiner YES NO Number Initial П  $\boxtimes$ C25D 11/19/2001 WO 01/90446 **B1** B2 П П **B3 B4** В5 OTHER ART Including Author, Title, Date, Pertinent Pages, Etc. \*Examiner Initial United States Patent Application for 09/614,407, filed on July 11, 2000. (AMAT/4471.Y1) (KIR) C1 <del>G2</del> **Date Considered** une 12 Robert R. Knehlo Examiner \*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

Sheet 1 of 1 sheet(s)

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			U.S. PATENT	DOCUMENTS	
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Initials*	No.'	Number-Kind Code <sup>2 (Flanours)</sup>	MM-DD-YYYY	Applicant of Cited Document	Figures Appear
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Sheet	2	of	2	Submission Date	March 24, 2004	

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Examiner	Rol	UCT R. Koehle Date Considered June 12,5	1004

'EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional), 2 Applicant is to place a check mark here if English language Translation is attached.

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Submission Date

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April 29, 2004

Examiner Voltable. Khelle Date Considered Anne I Saboth

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Filing Date	May 10, 2001
First Named Inventor	Hey, et al.
Group Art Unit	1753
Examiner Name	Robert R. Koehler
Attorney Docket Number	AMAT/4582/CMP/ECP/RKK
Submission Date	April 29, 2004

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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	Τ²
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Application Number

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